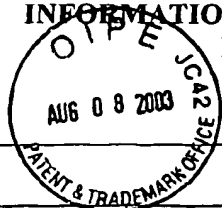


**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**



Attorney Docket Number	4641-59261
Application Number	09/881,445
Filing Date	June 13, 2001
First Named Inventor	Ushio
Art Unit	2818
Examiner Name	Not yet assigned

U.S. PATENT DOCUMENTS

Examiner's Initials*	Cite No. (optional)	Number	Date	Name
MB		4,645,349	Feb. 24, 1987	Tabata
MB		4,744,660	May 17, 1988	Noguchi <i>et al.</i>
MB		5,696, 583	Dec. 9, 1997	Yoon
MB		5,893,796	Apr. 13, 1999	Birang <i>et al.</i>
MB		5,964,643	Oct. 12, 1999	Birang <i>et al.</i>
MB		6,045,439	Apr. 4, 2000	Birang <i>et al.</i>
MB		6,280,290 B1	Aug. 28, 2001	Birang <i>et al.</i>
MB		US2001/0036805 A1	Nov. 1, 2001	Birang <i>et al.</i>
MB		6,537,133 B1	Mar. 25, 2003	Birang <i>et al.</i>

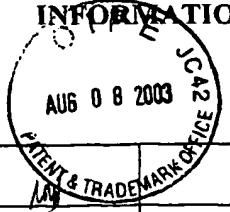
FOREIGN PATENT DOCUMENTS

Examiner's Initials*	Cite No. (optional)	Number	Date	Country
MB		56-153207 /	Nov. 27, 1981	Japan (w/English abstract)
MB		60-305 /	Jan. 5, 1985	Japan (w/English translation of relevant part)
MB		61-76904 /	April 19, 1986	Japan (corresponds to US 4,645,349)
MB		61-235708 /	Oct. 21, 1986	Japan (corresponds to US 4,744,660)
MB		63-50703 /	March 3, 1988	Japan (w/English translation of relevant part)
MB		64-57107 /	March 3, 1989	Japan (w/English translation of relevant part)
MB		6-147838 /	May 27, 1994	Japan (w/English translation)

EXAMINER
SIGNATURE: *MB*

DATE
CONSIDERED: *3-12-04*

* Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Attorney Docket Number	4641-59261
				Application Number	09/881,445
				Filing Date	June 13, 2001
				First Named Inventor	Ushio
				Art Unit	2818
				Examiner Name	Not yet assigned
		6-252113 /	Sept. 9, 1994	Japan (w/English translation)	
		8-145631 /	June 7, 1996	Japan (corresponds to US 5,696,583)	
		9-7985 /	Jan. 10, 1997	Japan (corresponds to US 6,537,133)	
		EP 0824995 A1 /	Feb. 25, 1998	EPC	
		EP 0738561 B1 /	Jan. 23, 2002	EPC	
Examiner's Initials*	Cite No. (optional)	OTHER DOCUMENTS			
MS	/	Ushio <i>et al.</i> , "In-situ monitoring of CMP process utilizing 0-order spectrometry," <i>CMP-IMC Conference</i> , pp. 23-29, Feb. 11-12, 1999			
MP	/	Ushio <i>et al.</i> , "In-situ monitoring of CMP process utilizing 0-order spectrometry," <i>IMIC Journal on CMP</i> , Vol. 1, No. 1, Fall, 1999			

EXAMINER SIGNATURE: <i>MS</i>	DATE CONSIDERED: 3-12-04
* Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.	

INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Docket: 4641-59261		App: (Unknown)	
				Applicant: Ushio et al.			
				Filed: June 13, 2001		Art Unit: (Unknown)	
U.S. PATENT DOCUMENTS							
Init.*		Number	Date	Name	Class	Sub	Filed
<i>ML</i>		6,102,775	8/15/00	Ushio et al.			
FOREIGN PATENT DOCUMENTS							
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<i>DL</i>		10311708	24.11.98	Japan (English Abstract Only)			
OTHER DOCUMENTS							
EXAMINER: <i>mm</i>				DATE <i>10-27-04</i>			
*Examiner: Initial if considered, whether or not in conformance with MPEP 609; draw line through cite if not in conformance and not considered. Send copy.							



INFORMATION DISCLOSURE STATEMENT

BY APPLICANT

Docket: 4641-59261

App: 09/881,445

Applicant: Ushio et al.

Filed: June 13, 2001

Art Unit: 2818

U.S. PATENT DOCUMENTS

Init.*		Number	Date	Name	Class	Sub	Filed

FOREIGN PATENT DOCUMENTS

		Number	Date	Country	Class	Sub	
<i>MD</i>		JP63-050703	3/3/98	Japan With English Abstract	—	—	
<i>MD</i>		JP64-057107	3/3/89	Japan With English Abstract	—	—	
<i>MD</i>		JP06-252113	9/9/94	Japan With English Abstract	—	—	

OTHER DOCUMENTS

EXAMINER:

MD

DATE

3-12-04

*Examiner: Initial if considered, whether or not in conformance with MPEP 609; draw line through cite if not in conformance and not considered. Send copy.